

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/595,607	KORVA ET AL.	
	Examiner Shih-Chao Chen	Art Unit 2821	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
343	700MS	12/11/2007	CHEN
343	702, 728	12/11/2007	CHEN